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Posted Date: 12 July 2023

doi: 10.20944/preprints202307.0802.v1

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Article

Measurement Uncertainty Analysis of the Stitching Linear-Scan Method for the Measurable Dimension of Small Cylinders

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Abstract: To verify the reliability of the proposed stitching linear scan method for roundness measurement of small cylindrical workpieces, measurement uncertainties of the workpieces with various dimensions are conducted. The cross-sectional circle of a cylindrical workpiece is divided into several equal arcs to be measured. Thus, the arc profile can be characterized according to the measured arcs. The roundness profile of the cylindrical part can be obtained by stitching these arc profiles together. Firstly, the measurement uncertainty of the workpiece with a diameter of 1.5 mm and length of 5.8 mm is evaluated to be 0.095 μm which can meet the uncertainty target of 0.1 μm . Considering the uncertainty of θ_x and θ_z which are the alignment around X-axis and Z-axis respectively changing with workpiece dimension changing, relevant uncertainties are carried out. As a result, there is no limitation with respect to workpiece diameter theoretically. If the alignment can reach $\theta_z = \theta_x = \pm 0.1^\circ$ without considering the measurable range of the machine.

Keywords: small cylinder; roundness; measurement uncertainty; linear-scan

1. Introduction

Fine mechanics, such as RV reducers, play a significant role in industrial robot and machine tool spindles. There are many cylindrical parts with various diameters employed in RV reducers. The performance and life of an RV reducer are affected by the quality of these cylindrical parts very much [1–5]. The parameter of roundness and diameter is always used to evaluate the quality of the cylindrical parts. The more precision the parameter is, the better the quality is. To enhance the quality of the cylindrical parts, precision measurement is necessary [6–11]. Conventionally, roundness measurement can be carried out by the rotary scan method with a roundness measuring machine [12–15]. In recent years, some alternative roundness measurement methods have been proposed, such as the multiple probe method and online method [16–19]. However, due to the crucial alignments (Inclination and eccentricity) of the rotary scan method, precision roundness measurement become difficult when the diameter of the measured workpiece becomes smaller. To address this issue, the stitching linear scan method is proposed [20–22]. In this method, the coordinates of the cross-sectional circle of the cylindrical workpiece which is attached to a round magnetic jig and mounted on a V-groove, are divided into several equal arcs to be scanned linearly by a profilometer. A set of arc coordinate data can be obtained after one linear scan on the surface of the cylindrical workpiece. The measured cylindrical workpiece is rotated by an equal angle to a new measuring position by rotating the magnetic jig and then scanned again. Another set of arc data can be obtained. Repeat the procedure by several times till the entire cross-sectional circle of the cylindrical workpiece is scanned completely, then a series of arcs can be obtained. The arc profiles, which can be characterized according to the obtained arcs, are used to stitch into a roundness profile. Through the stitching angle

error compensation, overlap parts integration, and filter processing, an accurate, integral, smooth, continuous roundness profile can be obtained [20–22].

Although small cylindrical parts can be measured by the stitching linear scan method, the measurable range of this method hasn't been analyzed. In this paper, measurement uncertainty is used to verify the reliability of the stitching linear scan method for the roundness measurement of small cylindrical parts with various diameters. Due to ambiguous between random error and system error, the concept of measurement uncertainty is proposed in 1993. The measured result can be reasonably and quantitatively evaluated according to GUM (Guide to the Expression of Uncertainty in Measurement) which is actually an error propagation [23–26]. The measurement uncertainty is necessary for multiple disciplines, such as survey measurement uncertainty, IoT sensor uncertainty, rainfall measurement, standardized track insulation measurement, etc [27–30]. In this paper, the analysis of measurement uncertainty is presented and the measurable range of the cylindrical workpiece can be confirmed.

2. Principles and Experiment

As is known to all, the surface form of a measured workpiece can be modeled and reconstructed by coordinates. In this paper, the coordinates of the cross-sectional circle of a small cylindrical workpiece are divided into several equal arcs to be scanned by a profilometer. The diameter and center coordinates of these arcs can be fitted by the least square method. The arc profiles can be characterized according to the arc data. The roundness profile of the small cylindrical part can be obtained by stitching these arc profiles one by one in sequence.

As shown in Figure 1(a), the small cylindrical workpiece with a diameter of 1.5 mm and length of 7.8 mm is attached to the circular magnetic jig which is marked by 8 equal lines on the surface. This kind of combination is mounted on the V-groove. As shown in Figure 1(b), the stylus of the profilometer is brought to scan on the surface of the small cylindrical workpiece and return to the initial position, then the first arc coordinate data can be obtained. The small cylindrical workpiece is rotated by 45° by rotating the circular magnetic jig by one equal part. The stylus scans on the surface of the workpiece again and returns, then the second arc coordinate data can be obtained. Repeat the procedure by 7 times, then 8 arc coordinate data can be obtained. Since the maximum measuring inclination of the stylus is $\pm 45^\circ$, only 85° arc coordinate data is extracted for the following data processing.

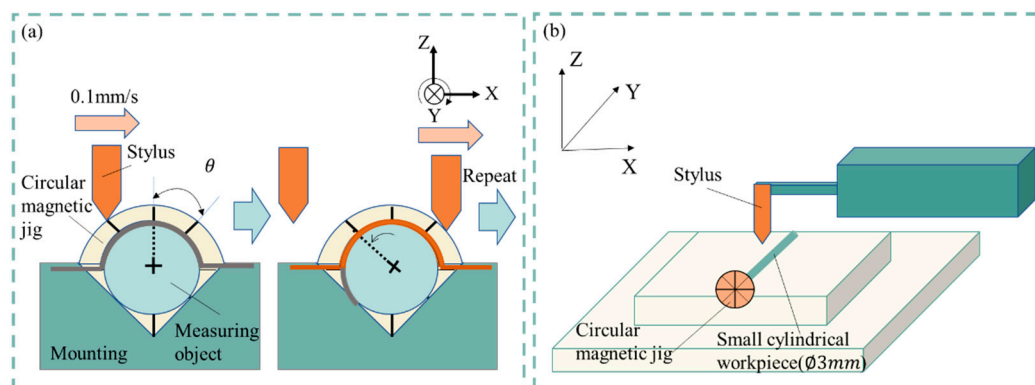


Figure 1. (a) Linear scan with a stylus; (b) Small cylinder mounted on the V-groove and scanned linearly.

The 8 arc profiles with respect to the arc coordinate can be characterized by a series of data processing. An inaccurate roundness profile can be formed by stitching these 8 arc profiles together. Regarding the stitching procedure, as shown in Figure 2(a)&(b), arc profiles 1 and 2 are at the initial position. As shown in Figure 2(c), the first arc profile is kept static and the second arc profile is rotated by 45° since there is a 45° angular displacement between adjacent arc profiles according to the measuring procedure. As shown in Figure 2(d) the second arc profile is kept static, and the third arc

profile is rotated by 45°, and the rest of the arc profiles are stitched in this manner. However, there are some stitching angle errors between adjacent arc profiles since the small cylindrical workpiece is rotated manually, namely, the angular displacement between adjacent arc profiles is not always 45°. Therefore, stitching angle error compensation is necessary. An accurate, integral, smooth, continuous roundness profile can be obtained after stitching error compensation, overlap part combination, and low-pass filter.

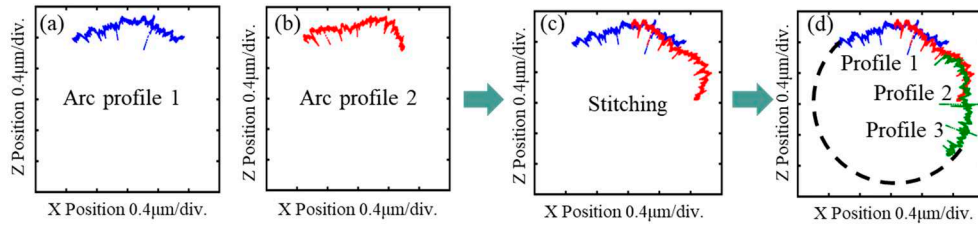


Figure 2. The stitching procedure: (a) Profile 1; (b) Profile 2; (c) The stitching of Profiles 1&2; (d) The stitching of the rest of the arc profiles.

3. Measurement uncertainty analysis of the linear-scan method

3.1. Building mathematical models

The uncertainty of the proposed linear-scan measurement method was evaluated in a measurement experiment of a small cylindrical workpiece with a small diameter of 1.5 mm and a length of 7.8 mm. A mathematical model was constructed to calculate the measurement uncertainty of the diameter and roundness. The arc output (x_i, z_i) in the rectangular coordinate system is obtained from the scanning of the linear scanning stylus. The mathematical model for the radius calculation and the uncertainty factors arising from the measurements are shown in Figure 3(a). For the radius calculation, a perfect circle is assumed, and the center of the circle is set to the origin. The radius R_i of an arbitrary measurement point is expressed in terms of the Z-axis output z_i and X-axis coordinates x_i of any measurement point using the following equation.

$$R_i = \sqrt{x_i^2 + z_i^2} \quad (1)$$

From equation (1), the combined standard uncertainty $u(R_i)$ of the measured arc radius is expressed as:

$$u^2(R_i) = \left(\frac{\partial R_i}{\partial x_i}\right) u^2(x_i) + \left(\frac{\partial R_i}{\partial z_i}\right) u^2(z_i) = \frac{x_i^2}{z_i^2 + x_i^2} u^2(x_i) + \frac{z_i^2}{z_i^2 + x_i^2} u^2(z_i) \quad (2)$$

The uncertainty coefficients in the figure are:

(1) Uncertainty coefficient of output z_i in the Z-axis direction.

$u(e_{\text{calibration}_Z})$: Uncertainty of stylus calibration in the Z-axis direction.

$u(e_{\text{resolution}})$: Uncertainty due to stylus resolution.

$u(e_{\text{repeat}})$: Uncertainty of repeated measurements.

(2) Uncertainty coefficient of output x_i in the X-axis direction

$u(e_{\text{calibration}_X})$: Uncertainty of stylus calibration in the X-axis direction.

$u(e_{\text{alignment}_Z})$: Uncertainty due to orientation error around the Z-axis of the workpiece.

$u(e_{\text{alignment}_X})$: Uncertainty due to orientation error around the X-axis of the workpiece.

In summary, the combined standard uncertainty z_i of the Z-axis output and the combined standard uncertainty of the X-axis coordinate x_i are expressed by the following equations (3) and (4), respectively.

$$u^2(z_i) = u^2(e_{\text{calibration}_Z}) + u^2(e_{\text{resolution}}) + u^2(e_{\text{repeat}}) \quad (3)$$

$$u^2(x_i) = u^2(e_{\text{calibration}_X}) + u^2(e_{\text{alignment}_Z}) + u^2(e_{\text{alignment}_X}) \quad (4)$$

For the calculation of roundness, it is assumed that there is a deviation from the approximate circle center rather than the radius of a perfect circle, and the approximate circle center is set as the

origin. The radius R_i of any measurement point, the radius R_0 of the vertex, and the X-axis coordinate x_i are used to represent the Z-axis output z_i of any measurement point with the following equation.

$$z_i = R_0 - \sqrt{R_i^2 - x_i^2} \quad (5)$$

The radius R_i after the stitching process is calculated according to Equation (6).

$$u(\Delta z_i) = u(\Delta r(\theta)_{max}) + u(\Delta r(\theta)_{min}) \quad (6)$$

Δr_i is the radial deviation at any measured point and Δr_0 is the radial deviation at the arc apex.

$$R_i = \bar{R} + \Delta r_i (\bar{R} \gg \Delta r_i) \quad (7)$$

$$R_0 = \bar{R} + \Delta r_0 (\bar{R} \gg \Delta r_0) \quad (8)$$

Square both sides of equation (5), substitute into equations (7) and (8), and rearrange.

$$\Delta r_i = \frac{2\bar{R}z_i - z_i^2 - x_i^2}{2\bar{R}} \quad (9)$$

From Eq. (9), the combined standard uncertainty $u(\Delta r_i)$ of the radial deviation of any measurement point can be expressed as:

$$\begin{aligned} u^2(\Delta r_i) &= \left(\frac{\partial \Delta r_i}{\partial \bar{R}}\right)^2 u^2(\bar{R}) + \left(\frac{\partial \Delta r_i}{\partial x_i}\right)^2 u^2(x_i) + \left(\frac{\partial \Delta r_i}{\partial z_i}\right)^2 u^2(z_i) \\ &= \left(\frac{x_i^2 + z_i^2}{2\bar{R}^2}\right)^2 u^2(\bar{R}) + \left(-\frac{x_i}{\bar{R}}\right)^2 u^2(x_i) + \left(1 - \frac{z_i}{\bar{R}}\right)^2 u^2(z_i) \end{aligned} \quad (10)$$

The uncertainty factors shown in Figure 3(b) are similar to the radius measurement model described above. Therefore, the combined standard uncertainty z_i for the Z-axis output and the combined standard uncertainty for the X-axis coordinate x_i are expressed by Eq. (6) and Eq. (7), respectively. The uncertainty of the radius after the suturing process is expressed by the following equation, using the combined standard uncertainty $u(R_i)$ of the radius obtained from Eq. (6) and the number of arc divisions N .

$$u(\bar{R}) = \frac{u(R_i)}{\sqrt{N}} = \frac{u(R_i)}{\sqrt{8}} \quad (11)$$

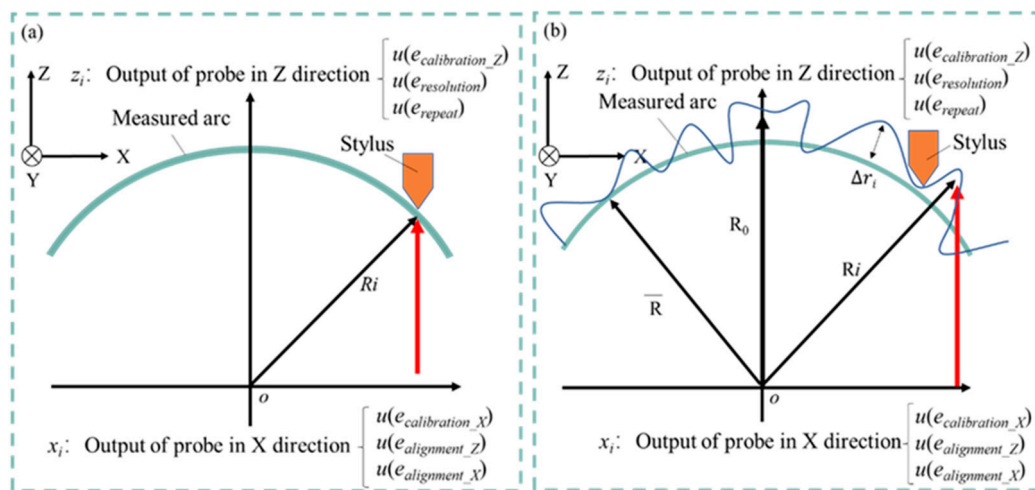


Figure 3. (a) Schematic of the radius measurement and the uncertainty components; (b) Schematic of the roundness measurement and the uncertainty components.

3.2. Measurement uncertainty evaluation

1. Uncertainty coefficient of output z_i in the Z-axis direction.

The standard uncertainty of each uncertainty factor is derived using appropriate evaluation methods.

(1) Uncertainty of stylus calibration in Z-axis direction $u(e_{calibration_Z})$.

The calibration of the Form Talysurf PGI420 used was performed with the dedicated master sphere shown in Figure 4(a). The Pt value is the minimum maximum width after linear expansion of the arc measured at the known radius value shown in Figure 4(b), including shape error of the master sphere, shape error of the stylus tip diameter, electrical noise in the system, and mechanical and environmental disturbances Pt value = $0.0337\mu\text{m}$ is in the radial direction, but assuming the presence in the Z-axis and X-axis directions, respectively, and a larger estimate, the uncertainty of the stylus calibration in the Z-axis direction uncertainty can be expressed by the following equation.

$$u(e_{\text{calibration}_Z}) = 0.0337\mu\text{m} = 33.7\text{nm} \quad (12)$$

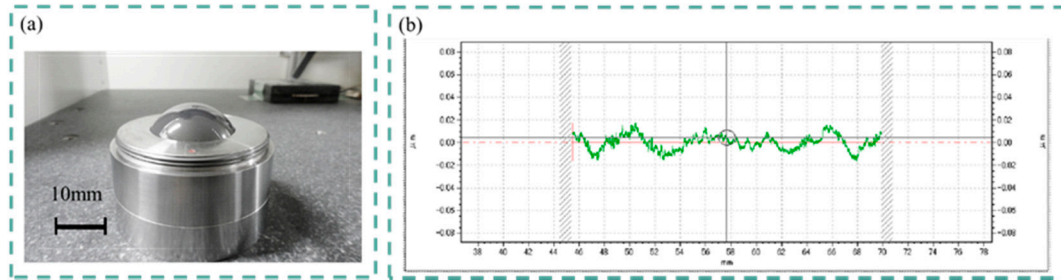


Figure 4. (a) Standard ball; (b) Calibration Result.

(2) Uncertainty due to stylus resolution $u(e_{\text{resolution}})$.

The Form Talysurf PGI420 uses a linear scanning stylus with a vertical resolution of 3.2 nm. The uncertainty due to the resolution of the stylus is considered to be a ± 1.6 nm rectangular distribution, which can be determined using the Type B evaluation method by the following equation.

$$u(e_{\text{resolution}}) = \frac{3.2/2}{\sqrt{3}} = 0.92\text{nm} \quad (13)$$

(3) Uncertainty of repeated measurements $u(e_{\text{repeat}})$.

The results of repeated measurements using the Form Talysurf PGI420 on the cross-sectional circle of a small cylindrical workpiece with a diameter of 1.5 mm were used to estimate the uncertainty due to measurement error: The repeatability was 59.93 nm based on 10 repeated measurements, and the uncertainty of the repeated measurements can be determined using the Type A evaluation method according to the following formula.

$$u(e_{\text{repeat}}) = \frac{59.93}{\sqrt{10}} = 18.95\text{nm} \quad (14)$$

2. Uncertainty coefficient of the x-axis coordinate x_i .

(1) Uncertainty of stylus calibration in the X-axis direction $u(e_{\text{calibration}_X})$.

When picking up the output z_i in the Z-axis direction as the uncertainty coefficient, it is assumed that Pt values exist in the Z-axis and X-axis directions, respectively, so the uncertainty of the stylus calibration in the X-axis direction is the same as that in the X-axis direction, expressed by the following equation.

$$u(e_{\text{calibration}_X}) = 33.7\text{nm} \quad (15)$$

(2) Uncertainty due to orientation error around the Z-axis of the workpiece $u(e_{\text{alignment}_Z})$.

The uncertainty caused by the workpiece attitude error is calculated by establishing a mathematical model of the measurement error, and the calculated value of the measurement error is used to determine the uncertainty by B-type evaluation. Figure 5(a) shows a schematic diagram of the effect of the orientation error of a cylindrical workpiece around the Z-axis. The diameter of the workpiece is D, the radius is R, the coordinates of the acquired arc endpoints are $(x_{\text{edge}}, z_{\text{edge}})$, and the angle of the attitude error is θ_z . The attitude error around the Z-axis causes the measurement result of the geometric circle of the geometric cylinder to appear as an ellipse with its main axis in the X-axis direction. An error occurs in the X-axis coordinates because an arc of $\varphi = 85^\circ$, i.e., an arc of height h from the vertex, is extracted regardless of the workpiece diameter, as shown in Equation (17). If the

error angle is $\pm\theta_z^\circ$ and this error has a rectangular distribution, the uncertainty due to the posture error around the Z-axis is represented by the following equation.

$$h = R \times (1 - \cos \frac{\varphi}{2}) \quad (16)$$

$$u(e_{alignment_z}) = \frac{x_{edge}}{\cos \frac{\theta_z}{\sqrt{3}}} - x_{edge} = R \sin \frac{\varphi}{2} (\frac{1}{\cos \frac{\theta_z}{\sqrt{3}}} - 1) \quad (17)$$

In the actual measurement, the alignment of the rotary table and the scanning of the stylus were repeatedly performed so that the obtained arc length converged to the minimum and the error angle θ_z was measured as small as possible. Assuming an error angle of $\pm 1^\circ$ at this point, the uncertainty due to the pose error around the Z-axis can be obtained by substituting the radius after the stitching process into equation (18) as follows.

$$u(e_{alignment_z}) = 0.74940 \times \sin \frac{85^\circ}{2} \left(\frac{1}{\cos \frac{1^\circ}{\sqrt{3}}} - 1 \right) = 0.00002568mm = 25.68nm \quad (18)$$

(3) Uncertainty due to orientation error around the X-axis of the workpiece $u(e_{alignment_z})$.

Figure 5(b) shows a schematic diagram of the effect of the attitude error around the X-axis on a cylindrical workpiece. The diameter of the workpiece is D , the radius is R , the coordinates of the arc endpoints are obtained as (x_{edge}, z_{edge}) , and the angle of the orientation error is θ_x . The orientation error around the X-axis causes the measurement of the geometric circle of the geometric cylinder to appear as an ellipse of the main axis in the Z-axis direction. The error in the X-axis coordinates is because the arc of height h is extracted from the vertex, just as in the case of the directional error around the Z-axis. If the error angle is $\pm\theta_x^\circ$ and the error has a rectangular distribution, the uncertainty caused by the positional error around the X-axis is given as follows.

$$u(e_{alignment_x}) = x_{edge} - x_{edge} \cos \frac{\theta_x}{\sqrt{3}} = R \sin \frac{\varphi}{2} (1 - \cos \frac{\theta_x}{\sqrt{3}}) \quad (19)$$

In the actual measurement, the manual stage is moved in the Y-axis direction with the stylus in contact with the plane of the mounting table and aligned with the inclined stage to minimize displacement output variation. The error angle θ_x is measured as small as possible. Assuming that the error angle at this point is $\pm 0.1^\circ$, the uncertainty caused by the attitude error around the X-axis is obtained by substituting the radius after the stitching process into equation (9) as follows.

$$u(e_{alignment_z}) = 0.74940 \times \sin \frac{85^\circ}{2} \left(1 - \cos \frac{1^\circ}{\sqrt{3}} \right) = 0.00000257mm = 0.26nm \quad (20)$$

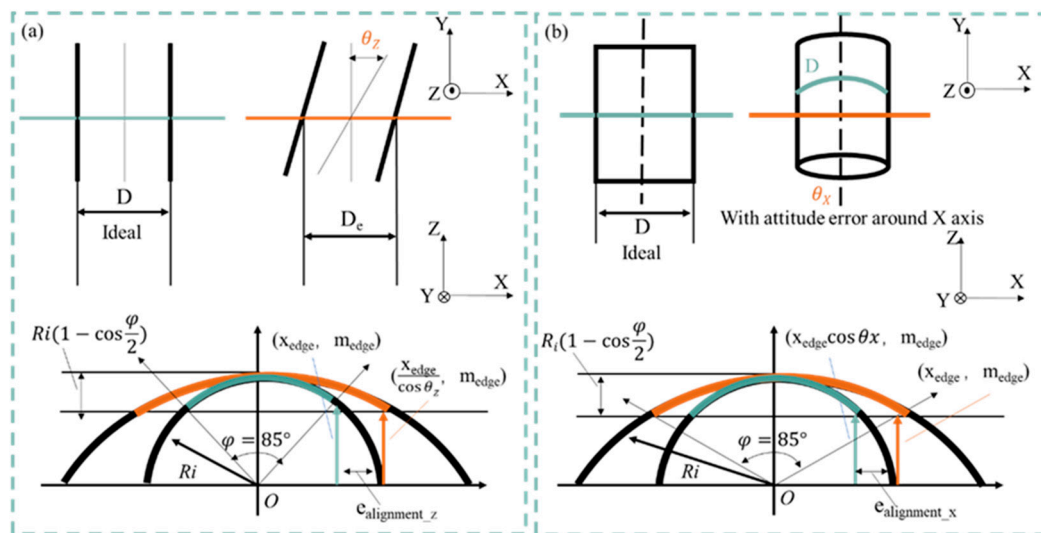


Figure 5. (a) Influence of attitude error of roll workpiece around Z-axis; (b) Influence of attitude error of roll workpiece around X-axis.

Tables 1 and 2 summarize the calculated results for each uncertainty. From these results, the combined standard uncertainty z_i for the Z-axis output and the combined standard uncertainty x_i for the X-axis coordinates can be expressed respectively by the following equations.

$$\begin{aligned} u(z_i) &= \sqrt{u^2(e_{\text{calibration}_Z}) + u^2(e_{\text{resolution}}) + u^2(e_{\text{repeat}})} \\ &= \sqrt{33.7^2 + 0.92^2 + 18.95^2} \\ &= 38.45\text{nm} \end{aligned} \quad (21)$$

$$\begin{aligned} u(x_i) &= \sqrt{u^2(e_{\text{calibration}_X}) + u^2(e_{\text{alignment}_Z}) + u^2(e_{\text{alignment}_X})} \\ &= \sqrt{33.7^2 + 25.68^2 + 0.26^2} \\ &= 42.37\text{nm} \end{aligned} \quad (22)$$

Table 1. Uncertainty budget of the output in the Z-axis direction.

Source of Uncertainty	Symbol	Type	Coverage factor	Standard uncertainty	Sensitivity coefficient	$ c_i \times u(x_i)$ nm
Calibration of probe	$u(e_{\text{calibration}_Z})$	A	—	33.7	1	33.7
Resolution	$u(e_{\text{resolution}})$	B	$\sqrt{3}$	0.92	1	0.92
Repeatability	$u(e_{\text{repeat}})$	A	—	18.95	1	18.95
Combined standard uncertainty	$u(z_i)$			—		38.45

Table 2. Uncertainty budget of the X-axis coordinate.

Source of Uncertainty	Symbol	Type	Coverage factor	Standard uncertainty	Sensitivity coefficient	$ c_i \times u(x_i)$ nm
Calibration of probe	$u(e_{\text{calibration}_X})$	A	—	33.7	1	33.7
Attitude error around Z-axis	$u(e_{\text{alignment}_Z})$	B	$\sqrt{3}$	25.68	1	25.68
Attitude error around X-axis	$u(e_{\text{alignment}_X})$	B	$\sqrt{3}$	0.26	1	0.26
Combined standard uncertainty	$u(x_i)$			—		42.37

Using the calculated uncertainty, the combined standard uncertainty $u(R_i)$ of the measured arc radius can be obtained from equation (23) as follows Substitute the combination of (x_i, z_i) , i.e., the coordinates of the arc endpoint $(x_{\text{edge}}, z_{\text{edge}}) = (0.50575, 0.55280)$, for which the $u(R_i)$ obtained from the measurement is the maximum.

$$\begin{aligned} u(\Delta r(\theta)) &= u(m(\theta)) = 26.92\text{nm} \\ u(R_i) &= \sqrt{\frac{x_i^2}{z_i^2 + x_i^2} u^2(x_i) + \frac{z_i^2}{z_i^2 + x_i^2} u^2(z_i)} \end{aligned} \quad (23)$$

$$= \sqrt{\frac{0.50575^2}{0.55280^2 + 0.50575^2} \times 42.37^2 + \frac{0.55280^2}{0.55280^2 + 0.50575^2} \times 38.45^2} = 40.28nm \quad (24)$$

The uncertainty of the radius after the suturing process can be obtained by substituting the values obtained in equation (13) into equation (11) to obtain the following equation.

$$u(\bar{R}) = \frac{u(R_i)}{\sqrt{8}} = \frac{40.28}{\sqrt{8}} = 14.24nm \quad (25)$$

The uncertainty of the diameter measurement is twice the uncertainty of the radius.

$$u(D) = 2 \times u(R_i) = 2 \times 14.24 = 28.48nm \quad (26)$$

Calculating the extended uncertainty for k=2 yields the following.

$$U(D) = ku(D) = 2 \times 28.48 = 56.96nm \quad (27)$$

As can be seen above, the uncertainty of the diameter measurement of the 1.5 mm small cylindrical workpiece using the linear scanning method, was estimated to be ± 47.24 nm, achieving a target measurement uncertainty within ± 0.1 μm . Table 3 summarizes the results of the standard uncertainty.

Table 3. Uncertainty budget of diameter measurement by proposal method.

Source of Uncertainty	Symbol	Type	Coverage factor	Standard uncertainty	Sensitivity coefficient	$ c_i \times u(x_i)$ nm
Output in Z-axis direction	$u(z_i)$	—	—	38.45	1	38.45
Coordinate of X-axis	$u(x_i)$	—	—	42.37	1	42.37
Combined standard uncertainty	$u(R_i)$			—		40.28
Radius after stitching process	$u(\bar{R})$			—		14.24
Diameter	$u(D)$			—		28.48
Expanded uncertainty(k=2)	$U(D)$			—		56.96

Using the calculated uncertainty, the combined standard uncertainty $u(\Delta r_i)$ of the radial deviation of any measured point can be obtained from Eq. (10) as follows Substituting the combination of (x_i, m_i) , the coordinates of the endpoint of the arc $(x_{edge}, z_{edge}) = (0.50575, 0.55280)$ and the radius after the stitching process, for which u obtained from the measurement $u(\Delta r_i)$ is maximum, the following equation is obtained.

$$u(\Delta r_i) = \sqrt{\left(\frac{x_i^2 + z_i^2}{2\bar{R}^2}\right)^2 u^2(\bar{R}) + \left(-\frac{x_i}{\bar{R}}\right)^2 u^2(x_i) + \left(1 - \frac{z_i}{\bar{R}}\right)^2 u^2(z_i)}$$

$$= \sqrt{\left(\frac{0.50575^2 + 0.55280^2}{2 \times 0.74940^2}\right)^2 \times 14.24^2 + \left(-\frac{0.50575}{0.74940}\right)^2 \times 42.37^2 + \left(1 - \frac{0.55280}{0.74940}\right)^2 \times 38.45^2}$$

$$= 34.84nm \quad (28)$$

Using the same assumptions as in equations (6) and (29), the combined standard uncertainty $u(\Delta z_q)$ of roundness can be expressed as follows.

$$u(\Delta z_q) = 2u(\Delta r(\theta)) \quad (29)$$

$$u(\Delta z_q) = 2u(\Delta r_i) \quad (30)$$

Substituting the uncertainty calculated in Eq. (26), the combined standard uncertainty $u(\Delta z_q)$ is obtained from Eq. (27), as shown in Equation (31) below.

$$u(\Delta z_q) = 2u(\Delta r_i) = 2 \times 34.84 = 69.68 \text{ nm} \quad (31)$$

Calculating the extended uncertainty for $k=2$, the following equation is obtained.

$$U(\Delta z_q) = ku(\Delta z_q) = 2 \times 69.68 = 139.36 \text{ nm} \quad (32)$$

As can be seen above, the uncertainty in the roundness measurement of a small cylindrical workpiece with a diameter of 1.5 mm was estimated to be ± 95.44 nm using the linear scanning method, achieving a target measurement uncertainty of ± 0.1 μm or less. Table 3 summarizes the results of the standard uncertainty.

3.3. Variation of uncertainty due to change in workpiece diameter

The purpose of calculating the measurement uncertainty when the workpiece diameter varies by simulation is to investigate the cylindrical workpiece diameter suitable for roundness measurement using a roundness measuring machine, which is a linear scanning type measurement method. Among the uncertainty coefficients described in the previous section, the uncertainty coefficient $u(e_{\text{alignment_Z}})$ due to the orientation error around the workpiece Z-axis and the uncertainty coefficient $u(e_{\text{alignment_X}})$ due to the orientation error around the workpiece X-axis vary significantly with the change of the workpiece diameter, while the others are considered to be almost unchanged. Using equations (13) and (14), the graphs of the uncertainty $u(x_i)$ in the x-axis coordinate as the workpiece diameter varies from 0.01 mm to 50.00 mm are shown in Figure 6(a) and (b). Figure 6(a) shows that $u(e_{\text{alignment_Z}})$ increases with increasing diameter and becomes almost the same as $u(x_i)$, but the change in $u(e_{\text{alignment_X}})$ is smaller. This means that $u(e_{\text{alignment_Z}})$ is the dominant factor in the variation of $u(x_i)$. This is due to the setting of the attitude error angles $\theta_z = \pm 1^\circ$ and $\theta_x = \pm 0.1^\circ$ considering the alignment method and stylus resolution, while θ_z is estimated to be greater than θ_x . Figure 7(a) shows the graphs representing the variation of the extended uncertainty $U(D)$ for diameter and the extended uncertainty $U(\Delta z_q)$ for roundness, created by substituting $u(x_i)$ and other standard uncertainties, which vary with workpiece diameter, showing that both $U(D)$ and $U(\Delta z_q)$ increase as the workpiece diameter increases due to the effect of $u(x_i)$. Figure 7(b) shows a graph for expanding the range of workpiece diameters from 0.01 mm to 10 mm. From this graph, it can be read that the conditions under which the target measurement uncertainty within ± 0.1 m of the workpiece diameter can theoretically be achieved are $U(D)$ of 5.58 mm or less and $U(\Delta z_q)$ of 2.11 mm or less when the attitude error angle $\theta_z = \pm 1^\circ$ and $\theta_x = \pm 0.1^\circ$.

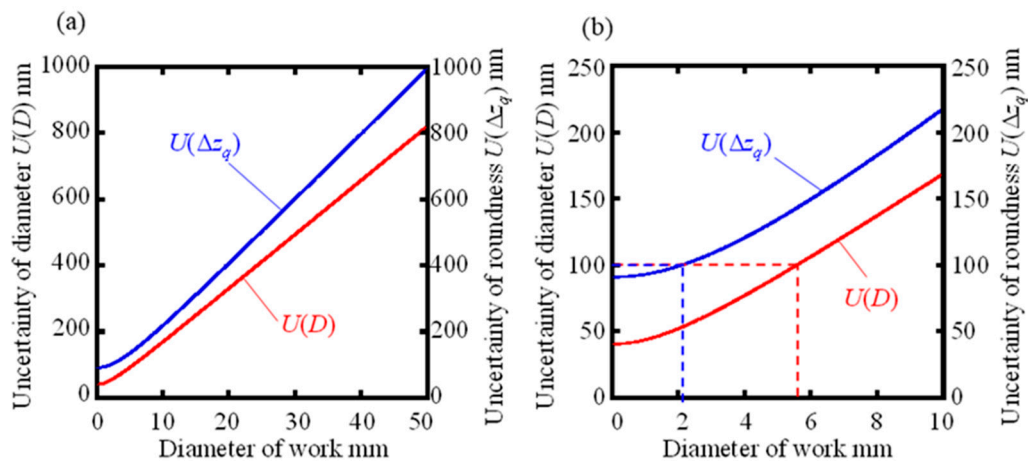


Figure 6. Variation of $u(x_i)$ in accordance with the diameter of workpiece: (a) Influence of $u(\Delta e_{\text{alignment_Z}})$; (b) Influence of $u(\Delta e_{\text{alignment_X}})$.

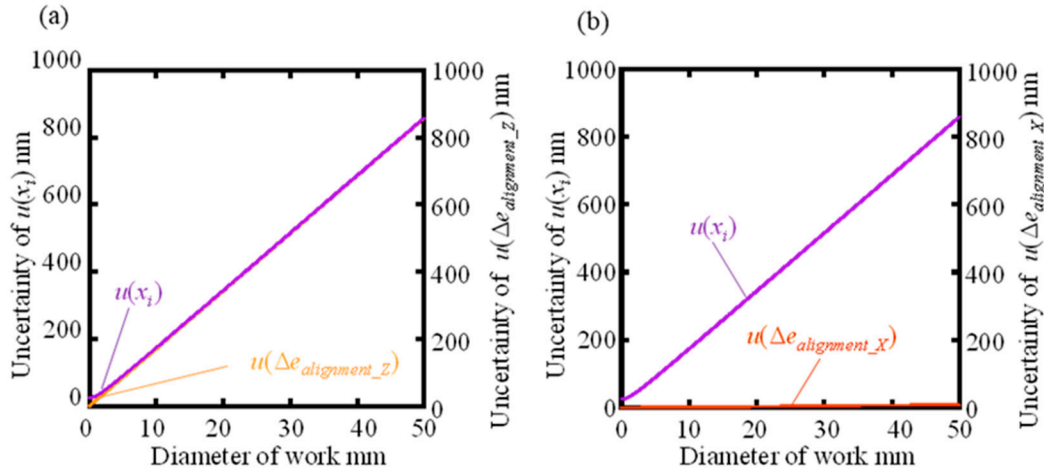


Figure 7. Variation of $U(D)$ and $U(\Delta zq)$ accordance with diameter of workpiece: (a) Diameter $\phi 0.01$ -50mm; (b) Diameter $\phi 0.01$ -10mm.

In the previous simulations, the attitude error angle was set to $\theta_z = \pm 1^\circ$ and $\theta_x = \pm 0.1^\circ$, but improving the alignment increases the upper limit of the workpiece diameter that satisfies the target measurement uncertainty. What has room for improvement is the attitude error angle θ_z around the Z-axis. Thus, Figure 8(a) and (b) show the extended uncertainty $U(D)$ in diameter and the extended uncertainty in roundness when the attitude angle error occurs in a rectangular distribution with $\theta_z = \pm 0.1^\circ, \pm 0.3^\circ, \pm 0.5^\circ, \pm 0.6^\circ, \pm 0.7^\circ, \pm 0.8^\circ, \pm 0.9^\circ, \pm 1^\circ, \pm 1.5^\circ$, and $\pm 2^\circ$. The variation of the uncertainty $U(\Delta zq)$. The upper limit of the workpiece diameter for which the target uncertainty of diameter and roundness can reach $\pm 0.1 \mu\text{m}$ at each attitude error angle θ_z is calculated from the graphs and summarized in Table 3. Table 3 shows that when measuring large-diameter cylindrical workpieces, it is desirable to make θ_z as convergent as possible by more precise alignment; if it can be kept less than $\theta_z = \pm 0.8^\circ$, the proposed method can cover all diameters below about 3 mm, which are difficult to measure with the rotary scanning method. The proposed method can cover all diameters less than 3 mm, which are difficult to measure with the rotational scanning method. If θ_z can be further reduced, the proposed method can also be used for workpieces with larger diameters; if the alignment can reach $\theta_z = \theta_x = \pm 0.1^\circ$, the diameter limitation of the workpiece theoretically no longer exists. However, as the workpiece diameter increases, the measurement range in the Z-axis and X-axis directions expands, which increases the uncertainty and limits the measurement range of the used measuring machine, which may lead to an upper limit of the workpiece diameter.

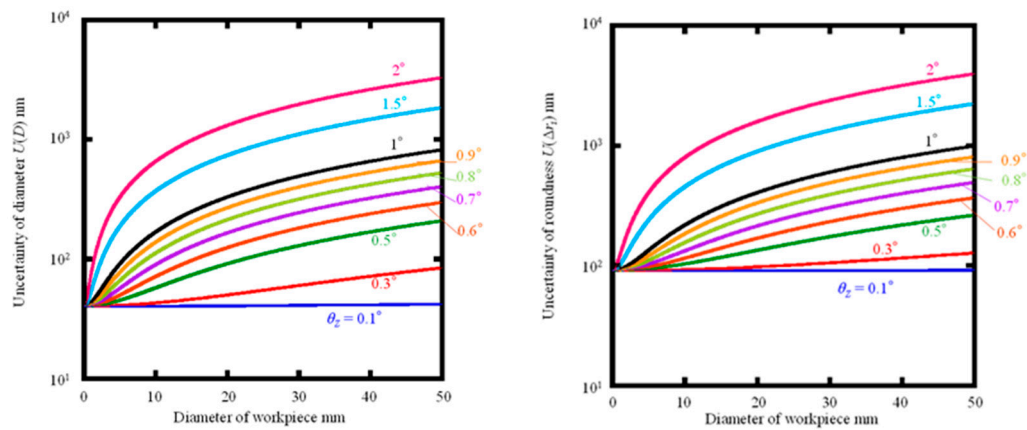


Figure 8. (a) Variation of $U(D)$ with a diameter of the workpiece; (b) Variation of $U(\Delta zq)$ accordance with diameter of workpiece.

4. Conclusions

To quantitatively assess the reliability of the stitching linear scan method for the roundness measurement of small cylindrical part with various diameters, a series of measurement uncertainties are carried out. Firstly, the measurement uncertainty of the workpiece with the diameter of 1.5 mm and length 5.8 mm is evaluated to be 0.095 μm which satisfies the target uncertainty of 0.1 μm . Since the alignment around X-axis (θ_x) and Z- axis (θ_z) are affected by different diameters of measured workpieces, the uncertainty caused by the alignment θ_x and θ_z should be analyzed. According to the analysis, the measurement uncertainties of the workpieces with the diameter from 0.01 mm to 50 mm are analyzed. All the error propagations are the same, except for the alignments of θ_x and θ_z , which are the position angle around X-axis and Z-axis respectively when the workpiece is mounted on the V-groove, are changing with the dimension of the workpiece changing. Evaluation results of the proposed stitching linear scan method confirm that if the position error θ_z around the Z-axis can be kept less than $\pm 0.8^\circ$, the proposed method can cover the roundness measurement of all diameters smaller than about 3 mm. It was confirmed that the proposed method can measure the roundness of all diameters less than about 3 mm, which are difficult to evaluate with roundness measuring machines, with an uncertainty within the target value if the attitude error angle θ_z around the Z axis is kept smaller than $\pm 0.8^\circ$. If θ_z can be further reduced, the proposed method can also be used for workpieces with larger diameters. If the alignment can reach $\theta_z = \theta_x = \pm 0.1^\circ$, there is no limitation with respect to workpiece diameter theoretically. However, with the workpiece diameter increasing, the measurement displacement in the Z-axis and X-axis is increasing which can beyond the limited range of the instrument, namely, the upper limitation of the roundness measurement by the stitching linear scan method is up to the measuring range of instrument.

Author Contributions: Jiali Zhao: Methodology; Resources; Formal analysis; Writing - original draft. Liang Zhang: Investigation; Data curation; Review & editing. Dan Wu: review & editing; Project administration. Bobo Shen: Data curation; Visualization. Qiaolin Li: Investigation; Visualization.

Funding: This research was funded by the National Defense Basic Scientific Research Program of China (Grant numbers JCKY2019427D002).

Data Availability Statement: The data that support the findings of this study are available from the corresponding author upon reasonable request.

Conflicts of Interest: The authors declare no conflict of interest.

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